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|  |      | Application Number       |              |
|  |      | Filing Date              | 2003 June 27 |
|  |      | First Named Inventor     | Namsoon Jung |
|  |      | Art Unit                 |              |
|  |      | Examiner Name            |              |
| Sheet 4  | of 4 | Attorney Docket Number   | AI-0005-FET  |

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| HA  |                       | L. RUI et al., Proc. 14th IEEE Intl. Conf. Automatic Face and Gesture Recognition, pp239-244, 2000  |                |
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| Examiner Signature | /Hadi Akhavannik/ (08/15/2006) | Date Considered | 08/15/2006 |
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Substitute for form 1449/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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| Examiner Name          |              |
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Sheet 1 of 4

## U. S. PATENT DOCUMENTS

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| HA  |                       | D. BEYMER, Proceedings IEEE Computer Society Conference on CVPR, pp921-928, 1996  |                |
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| HA  |                       | H.W. LEE et al., Proc. IEEE Intl. Symposium on Industrial Electronics, Vol1, pp254-259, 2001  |                |
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